

# United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

APPLICATION N	10.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/714,700		11/17/2003	Wen-Jian Lin	DEE-PT064.1	5380	
3624	7590	12/28/2004		EXAMINER		
·		ENIG, P.C.	DUONG, THOI V			
		UITE 1600		ART UNIT	PAPER NUMBER	
	H 17TH ST			ARTONII	TAFER NUMBER	
PHILAD	ELPHIA, F	'A 19103		2871 DATE MAILED: 12/28/2004		

Please find below and/or attached an Office communication concerning this application or proceeding.

.*			9hr			
	Application No.	Applicant(s)				
	10/714,700	LIN, WEN-JIAN				
Office Action Summary	Examiner	Art Unit				
	Thoi V Duong	2871				
The MAILING DATE of this communi Period for Reply	ication appears on the cover sheet with	the correspondence address -	,			
A SHORTENED STATUTORY PERIOD FOR THE MAILING DATE OF THIS COMMUNI  - Extensions of time may be available under the provisions after SIX (6) MONTHS from the mailing date of this common lift the period for reply specified above is less than thirty (30).  - If NO period for reply is specified above, the maximum states are period for reply within the set or extended period for reply Any reply received by the Office later than three months a earned patent term adjustment. See 37 CFR 1.704(b).	CATION. of 37 CFR 1.136(a). In no event, however, may a requinication. 0) days, a reply within the statutory minimum of thirty atutory period will apply and will expire SIX (6) MONT will, by statute, cause the application to become ABA	oly be timely filed  (30) days will be considered timely.  HS from the mailing date of this communication (NDONED (35 U.S.C. § 133).	ation.			
Status			Ý			
1) Responsive to communication(s) file	ed on <u>05 October 2004</u> .					
2a)⊠ This action is <b>FINAL</b> .	2b)☐ This action is non-final.					
	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
closed in accordance with the practic	ce under <i>Ex parte Quayle</i> , 1935 C.D.	11, 453 O.G. 213.				
Disposition of Claims						
4)⊠ Claim(s) <u>1-11</u> is/are pending in the a						
4a) Of the above claim(s) is/ai	re withdrawn from consideration.		:			
5) Claim(s) is/are allowed.						
6) Claim(s) 1-11 is/are rejected.						
7) Claim(s) is/are objected to.	ation and/or election requirement					
8) Claim(s) are subject to restric	, tion and/or election requirement.					
Application Papers						
9) ☐ The specification is objected to by the						
10) The drawing(s) filed on is/are:						
	ction to the drawing(s) be held in abeyand the correction is required if the drawing(s		21/4)			
11) The oath or declaration is objected to	•					
,—	by the Examinor. Note the diagnet					
Priority under 35 U.S.C. § 119	·					
<ul><li>12) Acknowledgment is made of a claim</li><li>a) All b) Some * c) None of:</li><li>1. Certified copies of the priority</li></ul>	for foreign priority under 35 U.S.C. § documents have been received.	119(a)-(d) or (f).				
2. Certified copies of the priority	documents have been received in Ap	plication No. <u>10/139852</u> .				
3. Copies of the certified copies	of the priority documents have been i	eceived in this National Stage	:			
• •	onal Bureau (PCT Rule 17.2(a)).					
* See the attached detailed Office actio	n for a list of the certified copies not r	eceived.				
Attachmont(s)	·					
Attachment(s)  1)  Notice of References Cited (PTO-892)	4) Interview S	ummary (PTO-413)				
<ol><li>Notice of Draftsperson's Patent Drawing Review (F</li></ol>	PTO-948) Paper No(s)	)/Mail Date				
<ol> <li>Information Disclosure Statement(s) (PTO-1449 or Paper No(s)/Mail Date</li> </ol>	PTO/SB/08) 5) \( \bigcap \text{Notice of In} \) 6) \( \bigcap \text{Other:} \( \bigcap \)	formal Patent Application (PTO-152)				

Page 2

Application/Control Number: 10/714,700

Art Unit: 2871

#### **DETAILED ACTION**

1. This office action is in response to the Reply filed October 05, 2004.

Claims 1, 2, 4-6, 8-10 and 13 are currently pending in this application.

## Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 1-11 are rejected under 35 U.S.C. 103(a) as being unpatentable over Kubo et al. (USPN 6,195,140 B1) in view of Yazawa et al. (USPN 4,431,272).

Re claim 1, as shown in Figs. 37 and 38, Kubo et al. discloses a method of manufacturing a thin film transistor liquid crystal structure comprising the steps of:

- (a) providing an insulating substrate 201;
- (b) forming a gate structure (gate electrode 210 and gate line 202) on a portion of said insulating substrate (Fig. 38A);
- (c) forming an insulating layer 209 (gate insulating film) on said insulating substrate (Fig. 38A);
- (d) forming a first semiconductor structure 212 and a second semiconductor structure 211 on said insulating layer (col. 32, lines 52-57);
- (e) forming a conducting layer 241 on said insulating layer and said second semiconductor structure (Fig. 38A and col. 32, lines 57-59);

Application/Control Number: 10/714,700

Art Unit: 2871

(f) etching said conducting layer to define a source region and a drain region 243 and a structure 242 (Fig. 38B and col. 32, lines 60-64); and

(g) forming a transparent electrode 246 on said structure, wherein said transparent electrode is electrically contacted with said source region and said drain region (Fig. 38D and col. 34, lines 1-9).

Re claim 7, as shown in Fig. 29 (see also Fig. 18), Kubo et al. discloses a thin film transistor liquid crystal display comprising:

an insulating substrate 70 (Fig. 18);

a thin film transistor 71 formed on said insulating substrate (Fig. 18);

a structure 170 formed on said insulating substrate (Fig. 29); and

a transparent electrode layer 168 formed on said structure (Fig. 18 and col. 27, lines 53-56).

Re claim 3, said conducting layer is formed from a metallic material (col. 4, lines 54-55).

Re claims 6 and 11, said transparent electrode is formed from indium-tin-oxide (col. 4, lines 56-57).

Kubo et al. discloses a method of manufacturing a thin film transistor that is basically the same as that recited in claims 1 and 7 except for a curved structure with an inclination.

As shown in Fig. 1c, Yazawa et al. discloses a conducting layer 18 (an aluminum electrode) having a curved structure with an inclination (rugged region 17) formed by etching the conducting layer 18 (col. 3, lines 59-62 and col. 4, lines 5-9),

Application/Control Number: 10/714,700

Art Unit: 2871

wherein, re claims 2 and 8, as shown in Fig. 4a, an angle "theta" of said inclination is about 5 to 30 degrees (col. 6, lines 58-64); and

wherein, re claims 4, 5, 9 and 10, said curved structure is an awl-shaped structure or a conical structure as shown in Figs. 4b and 11a.

Thus, it would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the method of manufacturing a thin film transistor liquid crystal structure of Kubo et al. with the teaching of Yazawa et al. by etching a conducting layer to form a curved structure with an inclination so as to enlarge viewing angle and improve brightness of the display (col. 1, line 63 through col. 2, line 12).

### Response to Arguments

4. Applicant's arguments filed October 05, 2004 have been fully considered but they are not persuasive.

Applicant argued that Yazawa does not teach or suggest the curved structure with an inclination formed by directly etching a conductive layer. The Examiner disagrees with Applicant's remarks since, as shown in Fig. 1c, Yazawa clearly discloses that the rugged region 17 (the curved structure with an inclination) is formed by directly etching the aluminum electrode 18 (col. 3, lines 59-62 and col. 4, lines 5-9). Thus, Yazawa teaches a similar method as Applicant's invention to provide an improved conductive layer for enlarging viewing angle and improving brightness of the display.

#### Conclusion

5. THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

Application/Control Number: 10/714,700

than SIX MONTHS from the mailing date of this final action.

Art Unit: 2871

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later

6. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thoi V. Duong whose telephone number is (571) 272-2292. The examiner can normally be reached on Monday-Friday from 8:30 am to 4:30 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Robert Kim, can be reached at (571) 272-2293.

Thoi Duong 🕏

12/21/2004

TARIFUR R. CHOWDHURY
PRIMARY EXAMINED

Page 5